

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In Re Application of:  Xuejun Kang, et al.  Application No. 10/572,524  Filed: September 11, 2007  For: FABRICATION OF CONDUCTIVE METAL LAYER ON SEMICONDUCTOR DEVICES	Examiner: Jeremy J. Joy  Art Unit: 2822  Confirmation No. 4739  <b>CERTIFICATE OF TRANSMISSION</b> I hereby certify that this correspondence is being submitted electronically via EFS Web on the date shown below.  /Adriana M. Garcia/ June 30, 2010 <i>Adriana M. Garcia</i> <i>Date</i>
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Mail Stop Amendment  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, Virginia 22313-1450

**AMENDMENT**

Sir:

In response to the Office Action mailed March 30, 2010, applicants respectfully request that the above-identified application be amended as follows.